



DT14 Rec'd PCT 20 OCT 2004 PATENT

Case Docket No. SAEG115.002APC
Date: October 18, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : NAKATSUKA, et al.
Appl. No. : 10/502,511
Filed : July 23, 2004
For : RADIOPROTECTIVE
MATERIALS AND
UTILIZATION THEREOF
Examiner : Unknown
Group Art Unit : Unknown

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Mail Stop Amendment, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 18, 2004

(Date)

Katsuhiro Arai, Reg. No. 43,315

TRANSMITTAL LETTER

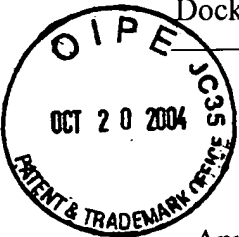
Commissioner for Patents
Mail Stop Amendment
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- (X) A PTO Form 1449 with seven (7) references.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

Katsuhiro Arai
Registration No. 43,315
Attorney of Record
Customer No. 20,995
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INFORMATION DISCLOSURE STATEMENT

Applicant : NAKATSUKA, et al.
App. No. : 10/502,511
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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:


Enclosed is form PTO-1449 listing seven (7) references that are also enclosed.

Please note that all publications are cited in the International Preliminary Examination Report issued during the international phase of the present application.

This Information Disclosure Statement is being filed with an RCE or within three months of the filing date of this application and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: October 18, 2004

By: 
Katsuhiro Arai
Registration No. 43,315
Attorney of Record
Customer No. 20,995
(949) 760-0404

FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.
SAEG115.002APCAPPLICATION NO.
10/502,511INFORMATION DISCLOSURE STATEMENT
BY APPLICANT

(USE SEVERAL SHEETS IF NECESSARY)

APPLICANT
NAKATSUKA, et al.FILING DATE
July 23, 2004GROUP
Unknown

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	1.	JP 01-280465	11/10/89	Japan			Abstract	
	2.	JP 09-241399	09/16/97	Japan			Abstract	
	3.	JP 10-338615	12/22/98	Japan			Abstract	
	4.	WO 98/55075	10/12/98	WIPO				
	5.	WP 99/17303	09/30/97	WIPO				
	6.	WO 01/45661 A2	12/11/00	WIPO				

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)	
	7.	Shin_ichiro Hiraide, "Research regarding the chemical reforming of the silk fibroin film," Research Report of Information Technology Research Institute of Nagano Prefecture, No. 17, p. 53-54 2001

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101804

EXAMINER	DATE CONSIDERED
*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.	